

FEB 13 2008

AGILENT TECHNOLOGIES, INC.
Legal Department, DL429
Intellectual Property Administration
P.O. Box 7599
Loveland, Colorado 80537-0599

ATTORNEY DOCKET NO. 10030753-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): Laura Mirkarimi

Serial No.: 10/765,647

Examiner: D. Vu Nguyen Deo

Filing Date: January 26, 2004

Group Art Unit: 1765

Title:

Method for Etching High Aspect Ratio Features in III-V Based Compounds for

COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria VA 22313-1450

TRANSMITTAL LETTER FOR RESPONSE/AMENDMENT

Sir:

Transmitted herewith is/are the following in the above-identified application:

- ☒ Response/Amendment ☐ Petition to extend time to respond
☐ New fee as calculated below ☐ Supplemental Declaration
☒ No additional fee (Address envelope to "Mail Stop Amendments")
☐ Other: (Fee \$ _____)

CLAIMS AS AMENDED BY OTHER THAN A SMALL ENTITY						
(1) FOR	(2) CLAIMS REMAINING AFTER AMENDMENT	(3) NUMBER EXTRA	(4) HIGHEST NUMBER PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	(6) RATE	(7) ADDITIONAL FEES
TOTAL CLAIMS		MINUS		= 0	X 50	\$ 0
INDEP. CLAIMS		MINUS		= 0	X 200	\$ 0
<input type="checkbox"/> FIRST PRESENTATION OF A MULTIPLE DEPENDENT CLAIM					+ 360	\$ 0
EXTENSION FEE	1 ST MONTH 120.00 <input type="checkbox"/>	2 ND MONTH 450.00 <input type="checkbox"/>	3 RD MONTH 1020.00 <input type="checkbox"/>	4 TH MONTH 1590.00 <input type="checkbox"/>		\$ 0
					OTHER FEES	\$ 0
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$ 0

Charge \$ 0 to Deposit Account 50-1078. At any time during the pendency of this application, please charge any fees required or credit any over payment to Deposit Account 50-1078 pursuant to 37 CFR 1.25. Additionally please charge any fees to Deposit Account 50-1078 under 37 CFR 1.16, 1.17, 1.19, 1.20 and 1.21. A duplicate copy of this transmittal letter is enclosed.

Respectfully submitted,

Laura Mirkarimi

By

William S. Francos
Attorney/Agent for Applicant(s)

I hereby certify that this paper is being facsimile
transmitted to the Patent and Trademark Office on
the date shown below:

Date of facsimile: February 13, 2008

Typed Name: William S. Francos

Signature: 

Reg. No. 38,456

Date: February 13, 2008

Telephone No. 610.375.3513

FEB 13 2008

Application Serial Number 10/765,647
Response to Office Action
Dated December 13, 2007

Reply under 37 CFR 1.116 – Expedited Procedure – TC 1700

**IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE**

Appl. No. : 10/765,647
Applicant(s): Laura Wills Mirkarimi
Filed: January 26, 2004
TC/A.U.: 1700/1765
Examiner: Duy Vy Nguyen Deo
Atty. Docket: 10030753-01
Confirmation No.: 1183
Title: Method for Etching High Aspect Ratio
Features in III-V Based Compounds for
Opto Electronic Devices

Reply under 37 CFR § 1.116 – Expedited Procedure – Technology Center 1700

Mail Stop--AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of December 13, 2007, please amend the above referenced application as follows and reconsider the application in light of the following remarks.

Application Serial Number 10/765,647
Response to Office Action
Dated December 13, 2007

Reply under 37 CFR 1.116 – Expedited Procedure – TC 1700

This paper includes (each beginning on a separate sheet):

1. Remarks/Discussion of Issues;